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Title: Plasma Boriding of a Cobalt-Chromium Alloy as an Interlayer for Nanostructured Diamond Growth

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Highlights:

- Metal-boride layer creates a compatible surface for NSD deposition
- PECVD boriding on CoCrMo produces robust metal-boride layer
- Deposition temperature comparison shows 750 °C boriding masks surface cobalt
- EDS shows boron diffusion as well as deposition
- Nanoindentation hardness of CoCrMo substantially increases after boriding

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